## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q84452

Michel PUECH

Appln. No.: 10/516,455

Group Art Unit: 1763

Confirmation No.: 2876

Examiner: Allan W. OLSEN

Filed: December 3, 2004

For:

METHOD AND DEVICE FOR SUBSTRATE ETCHING WITH VERY HIGH POWER

INDUCTIVELY COUPLED PLASMA

## RESPONSE TO RESTRICTION AND ELECTION OF SPECIES REQUIREMENTS

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This responds to the Restriction and Election of Species Requirement, dated December 18, 2006. In response to the Restriction Requirement, Applicant elects Group I, claims 1-4, drawn to plasma processing methods for examination. This election is made without traverse.

Applicant submits that if any of the elected claims is found to be allowable, claims dependent therefrom should similarly be considered allowable in the same application.

Applicant reserves the right to file a Divisional Application directed to non-elected claims 5-10.

## RESPONSE TO RESTRICTION AND ELECTION OF SPECIES REQUIREMENT U.S. Application No. 10/516,455

Q84452

The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,

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Date: May 18, 2007

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